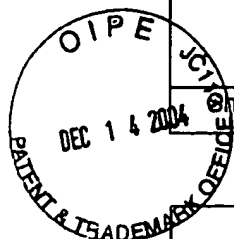


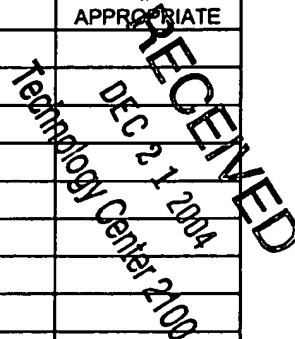
Subt. For, PTO-1449				Docket Number 19240-224		Application Number 09/775,350	
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>				Applicants Yechiam Yemini et al.			
				Filing Date 02/01/2001		Group Art Unit 2154 2143	
Sheet	1	OF	1				



U.S. Patent Documents						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)	



EXAMINER <i>[Signature]</i>	DATE CONSIDERED 7/27/05
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.	

Subt. For, PTO-1449

Docket Number

19240-224

Application Number

09/775,350

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicants

Yechiam Yemini *et al.*

Filing Date

02/01/2001

Group and Unit

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